

Inert and high energy emission environments

Model 20SX/25SX Vacuum Particle Sensors

FEATURES

- High power laser diode for 0.19 micron sensitivity and large detection area
- Ultra compact probe design
- In-chamber monitoring

CONFIGURATIONS

- VCR[®]
- Swagelok[®] Fitting
- Varian E-1000[™] Implant
- Eaton GSD[™] Implant
- Ulvac Disk CoaterL/L[™]
- AMAT XR80[™] Implant
- KF-25
- KF-40
- KF-50



The HYT Model 20SX and Model 25SX vacuum particle sensors detect particles in non-corrosive, vacuum process equipment. These laser-based sensors can be installed in loadlock or process chambers or into exhaust pump lines. They have been proven in highproduction fabs on tools such as sputtering systems and ion implanters.



Used in conjunction with an HYT controller, the Model 20SX and Model 25SX sensors facilitate process control by enabling users to monitor particles continuously and in real time. Complete *in situ* particle monitoring (ISPM) systems include the sensor, an HYT controller, Machine Trigger[™] capability which provides for synchronization of particle counts with the process cycle, and Particle Vision[®] software for data acquisition and analysis.

The Model 20SX sensor is compact, allowing installation in restricted spaces, while the Model 25SX may be mounted directly within a chamber or process module. T-shaped housings and custom vacuum adapters are available to facilitate sensor installation into different chambers and pump lines.

The Model 20SX and Model 25SX sensors are insensitive to high energy emissions, making them suitable for use in the presence of ion gauges and implanter flood guns.





Model 20SX/25SX Vacuum Particle Sensors

0.19 µm minimum detectable size		
20SX	20 mm² @ .22 µm	
	40 mm² @ .502 μm	
25SX	28 mm² @ .269 µm	
	40 mm² @ .502 μm	
810 nm, 150 mW emitted		
Class I laser pro	oduct when installed in a sealed vacuum system	
by trained personnel. Class IIIb laser when not installed.		
Complies with FDA radiation performance standards, 21 CFR		
1040.10 and 10	1040.10 and 1040.11 and with IEC 825-1:1993.	
0.3 to 4.0 m/se	c (standard)	
1.5 to 32 m/sec (with Filter Optio		
10 ⁻⁸ torr to 100 psi		
Operating	50 to 122°F (10 to 50°C)	
Storage	-40 to 185°F (-40 to 85°C)	
Exposure to temperatures above I04°F (40°C) during		
operation may	reduce laser life to less than one year.	
	20SX 25SX 810 nm, 150 m Class I laser pro by trained perso Complies with 1040.10 and 10 0.3 to 4.0 m/se 1.5 to 32 m/sec 10 ^s torr to 100 Operating Storage Exposure to ten	



SPECIFICATIONS







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